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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Anthony et al.

Docket:

TI-24953

Appl. No.:

09/116,138

Examiner:

A. Mai

Filed:

07/15/98

Art Unit:

2814

For:

High Permittivity Silicate Gate Dielectric

REQUEST FOR ENTRY OF CORRESPONDENCE UNDER 37 C.F.R. § 1.8(B)

February 25, 2003

Assistant Commissioner for Patents Washington, DC 20231

FACSIMILE CERTIFICATE

I hereby certify that this correspondence is being transmitted by Facsimile to the Patent and Trademark Office in accordance with 37

Examiner:

During an interview with the Examiner on February 24, 2003, Applicant became aware that the Patent and Trademark Office did not receive the NOTICE OF APPEAL or the AMENDMENT PURSUANT TO 37 C.F.R. § 1.116—INCLUDING A PROPOSED DRAWING SHEET W/ FIG 21 mailed by the applicant on April 15, 2002. On April 24, 2002 the Patent and Trademark Office did stamp a POSTCARD accompanying the correspondence.

Applicant hereby requests that Examiner enter the NOTICE OF APPEAL and the AMENDMENT PURSUANT TO 37 C.F.R. § 1.116 received on April 24, 2002, consider the papers to be timely filed, and to resume examination of the application.

A copy of the POSTCARD, NOTICE OF APPEAL, and the AMENDMENT PURSUANT TO 37 C.F.R. § 1.116—INCLUDING A PROPOSED DRAWING SHEET W/ FIG 21 are enclosed. Applicant respectfully requests a prompt response to this request so that the application may be examined and passed to issue.

Respectfully submitted,

David Denker Reg. No. 40,987

Texas Instruments Incorporated P. O. Box 655474, MS 3999 Dallas, Texas 75265 (972) 917-4388 Fax (972) 917-4418



A. Mai Cook The College of the Cook The IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of: Anthony et al.

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INTERVIEW SUMMARY

February 25, 2003

Ass't Commissioner for Patents Washington, DC 20231

MAILING CERTIFICATE UNDER 37 C.F.R. § 1.8 I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington,

DC 20231 on

Examiner:

This is a summary of the telephone interview between Examiner A. Mai (703-305-0575) and Applicants' agent, David Denker on February 24, 2003. The interview discussed the status of the application. Examiner noted that the notice of appeal—and its accompanying papers—mailed April 15, 2002, and received by the USPTO mailroom on April 24, 2002 was not entered in the file. I agreed to send in a 37 C.F.R. § 1.8b request for entry, so that the USPTO could resume examination of the application.

Respectfully submitted,

David Denker Reg. No. 40,987

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e "Received" stamp of the Patent and Trademark Office imprinted hereon acknowledges the filing of:			
NEW APPLICATION DECLARATION ASSIGNMENT FORMAL DRAWINGS INFORMAL DRAWINGS CONTINUATION APP'N DIVISIONAL APP'N		X AMENDMENT 1.116 EOT X NOTICE OF APPEAL APPEAL ISSUE FEE REPLY BRIEF (IN TRIPLICATE) X Proposed Drawing Sheet w/ Fig 21	
NAME OF INVENTOR(S):		RECEIPT DATE & SERIAL NO.:	
Anthony et al.		Serial No.: 09/116,138	
TITLE OF INVENTION: High Permittivity Silicate Gate Dielectric		O I P E	
TI FILE NO.:	DEPOSIT ACCT. NO.:	10	
TI-24953	20-0668	APR 2 4 2002	
EXP.MAIL RCPT. NO.:			
MLD: 4/15/02			
DUE: 4/15/02		TRACE	

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